

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

TOYOSAWA et al

Atty. Ref.: 1035-270

Serial No. 09/598,169

Group: 2811

Filed: June 21, 2000

Examiner: Vu, H.

For: A SEMICONDUCTOR DEVICE HAVING ACTIVE ELEMENT
CONNECTED TO AN ELECTRODE METAL PAD VIA A BARRIER METAL
LAYER AND INTERLAYER INSULATING FILM

* * * * *

June 24, 2004

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

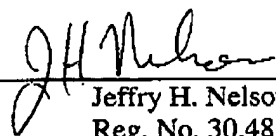
**REQUEST FOR EXAMINER TO CONSIDER PRIOR ART PREVIOUSLY
SUBMITTED**

An Information Disclosure Statement was filed on July 7, 2003 in the above-captioned application. However, the PTO-1449 form bearing the Examiner's initials next to each of these citations was not returned with the Notice of Allowance of July 28, 2004. It respectfully requested that the Examiner initial each of these citations in the attached PTO-1449 form and return them to Applicants' attorney.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By:


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FACSIMILE CERTIFICATE

I hereby certify that this Request is being transmitted
by facsimile to the Patent and Trademark Office
on August 9, 2004, specifically to 703-872-9306.


Jeffrey H. Nelson, Reg. No. 30,481

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